

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.:	10/565036	Confirmation No.:	7066
Applicant:	BECKER, <i>et al.</i>		
Filed:	18/JAN/2006		
TC/A.U.:	2829		
Examiner:	Hung, Ming Hung		
Docket No.:	DC5146 PCT1		
Customer No.:	00137		
Date:	10 October 2008		
For:	Method for Etching a Patterned Silicone Layer		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the office action dated 20 August 2008 please amend the above-identified application as follows.

Amendments to the Specification are on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 7 of this paper.